

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.	:	10/567,729	Confirmation No. 7682
Applicant	:	Kazutoshi Kojima et al.	
371 Filed	:	February 1, 2006	
Art Unit	:	2814	
Examiner	:	Sarah Kate Salerno	
Customer No.	:	00270	
Title	:	SILICON CARBIDE EPITAXIAL WAFER, METHOD FOR PRODUCING SUCH WAFER, AND SEMICONDUCTOR DEVICE FORMED ON SUCH WAFER	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This is an Amendment in timely response to a non-final Office Action dated March 31, 2009. Kindly amend the application as set forth below.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.